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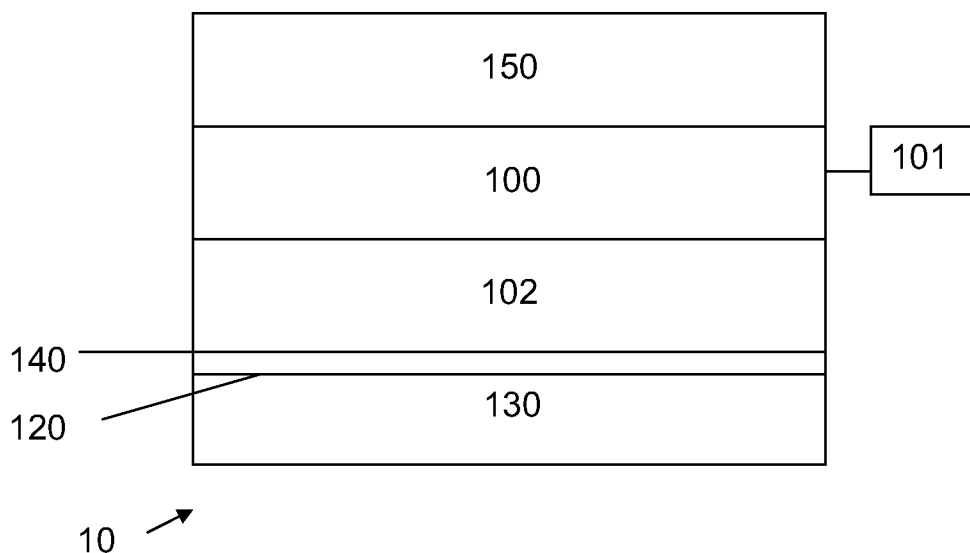
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Fig. 1



(57) Abstract: A photovoltaic cell can include a dopant in contact with a semiconductor layer.

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PHOTOVOLTAIC DEVICES INCLUDING DOPED SEMICONDUCTOR FILMS

CLAIM FOR PRIORITY

This application claims priority under 35 U.S.C. §119(e) to Provisional U.S. Patent Application No. 60/985,019, filed on 2 November 2007, which is hereby
5 incorporated by reference in its entirety.

TECHNICAL FIELD

This invention relates to photovoltaic cells.

BACKGROUND

10 During the fabrication of photovoltaic devices, layers of semiconductor material can be applied to a substrate with one layer serving as a window layer and a second layer serving as the absorber layer. The window layer can allow the penetration of solar energy to the absorber layer, where the optical energy is converted into electrical energy. Some photovoltaic devices can use transparent thin films that are also conductors of electrical
15 charge. The conductive thin films can be a transparent conductive oxide (TCO), such as fluorine-doped tin oxide, aluminum-doped zinc oxide, or indium tin oxide. The TCO can allow light to pass through a substrate window to the active light absorbing material and also serves as an ohmic contact to transport photogenerated charge carriers away from the light absorbing material. A back electrode can be formed on the back surface of a
20 semiconductor layer. The back electrode can include electrically conductive material, such as metallic silver, nickel, copper, aluminum, titanium, palladium, or any practical combination thereof, to provide electrical connection to the semiconductor layer. The back electrode can be a semiconductor material. Doping the semiconductor layer can improve the efficiency of a photovoltaic device.

SUMMARY

25 In general, a photovoltaic cell can include a transparent conductive layer and a first semiconductor layer in contact with the transparent conductive layer. The first semiconductor layer can include an oxidant. The transparent conductive layer can be positioned over a substrate. In other circumstances, the transparent conductive layer can

be positioned over the first semiconductor layer. The oxidant can be fluorine or oxygen, for example.

In some circumstances, a photovoltaic cell can include a layer between the transparent conductive layer and the first semiconductor layer, wherein the layer contains a dopant. The dopant can include an n-type dopant. A layer containing a dopant can be in contact with a first semiconductor layer. A layer containing a dopant can be in contact with the transparent conductive layer.

A photovoltaic cell can further include a second semiconductor layer in contact with a first semiconductor layer. The second semiconductor layer can include CdTe. The first semiconductor layer can include CdS. The substrate can be glass.

In some circumstances, a photovoltaic cell can further include an additional first semiconductor layer between the layer containing a dopant and the transparent conductive layer. The layer containing a dopant can have a thickness greater than 4 Angstroms. The layer containing a dopant can have a thickness greater than 8 Angstroms. The layer containing a dopant can have a thickness greater than 12 Angstroms.

In another aspect, a photovoltaic cell can include a transparent conductive layer, a first semiconductor layer in contact with the transparent conductive layer, and a second semiconductor layer adjacent to the first semiconductor layer, wherein the first or second semiconductor layer includes a dopant.

In some circumstances, both the first and second semiconductor layer can include a dopant. The dopant in the first semiconductor layer can be different from the dopant in the second semiconductor layer. A transparent conductive layer can be positioned over a substrate. A transparent conductive layer can be positioned over a first semiconductor layer. A first semiconductor layer can include CdS. A second semiconductor layer can include CdTe.

A dopant can be a Group III species. A dopant can be a Group I species. A dopant can be Cu, Ag, or Au. A dopant can be a Group V species. A dopant can have a concentration of greater than 0.5 ppma. A dopant can have a concentration greater than 100 ppma. A dopant can have a concentration greater than 500 ppma.

A method of manufacturing a photovoltaic cell can include depositing a first semiconductor layer in contact with a transparent conductive layer, depositing a second semiconductor layer adjacent to the first semiconductor layer, and introducing a dopant in the first semiconductor layer or the second semiconductor layer.

In some circumstances, a dopant can be introduced to both the first and second semiconductor layer. In some circumstances, the dopant introduced to the first semiconductor layer can be different from the dopant introduced to the second semiconductor layer.

5 A dopant can be introduced by diffusion. A dopant can be introduced by a vapor. A dopant can be introduced as a mixed powder. A dopant can be introduced as a solid powder. A dopant can be introduced throughout an entire semiconductor layer. A dopant can be added to a portion of a layer. A dopant can be an n-type dopant. A dopant can be a p-type dopant. A dopant can be indium and the mixed powder can be CdS and In₂S₃.

10 A dopant can be introduced during heat treatment. Heat treatment temperature can be about 400 degrees Celsius. A dopant can be applied to a surface of a second semiconductor layer prior to heat treatment.

 In another aspect, a method of manufacturing a photovoltaic cell can include depositing a first semiconductor layer in the presence of an oxidant and treating the first semiconductor layer with a dopant.

15 A first semiconductor layer can be positioned over a substrate. In other circumstances, a first semiconductor layer can be positioned over a metal layer. The transparent conductive layer can be positioned over the first semiconductor layer.

 An oxidant can be fluorine or oxygen. A dopant can include an n-type dopant. A dopant can include aluminum or indium. A dopant can be distributed as a layer within a first semiconductor layer.

 In another aspect, a system for generating electrical energy can include a multilayered photovoltaic cell, the photovoltaic cell including a transparent conductive layer, a first semiconductor layer in contact with a transparent conductive layer, and a second semiconductor layer over the first semiconductor layer, wherein the first or second semiconductor layer includes a dopant, a first electrical connection connected to the transparent conductive layer, and a second electrical connection connected to a metal layer.

 In some circumstances, both the first and second semiconductor layer can include a dopant. In some circumstances, the dopant in the first semiconductor layer can be different from the dopant in the second semiconductor layer.

The transparent conductive layer can be positioned over a substrate. A first semiconductor layer can be positioned over a metal layer. A transparent conductive layer can be positioned over the first semiconductor layer.

5 The details of one or more embodiments are set forth in the accompanying drawings and the description below. Other features, objects, and advantages will be apparent from the description and drawings, and from the claims.

DESCRIPTION OF DRAWINGS

FIG. 1 is a schematic of a substrate with multiple layers.

FIG. 2 is a schematic of a substrate with multiple layers.

10 FIG. 3 is a schematic of a substrate with multiple layers.

DETAILED DESCRIPTION

A photovoltaic cell can include a transparent conductive layer on a surface of the substrate, a first semiconductor layer, the substrate supporting the semiconductor layer, and a metal layer in contact with the semiconductor layer. The transparent conductive layer can be positioned over a substrate. In other circumstances, the transparent
15 conductive layer can be positioned over the first semiconductor layer.

A photovoltaic cell can include one or more oxidants or dopants. A photovoltaic cell can include a first semiconductor layer including a dopant or an oxidant, such as oxygen or fluorine. A photovoltaic cell can also include a layer containing a dopant, such
20 as an n-type dopant. A dopant can include a Group III species, such as aluminum or indium.

A layer containing a dopant can be positioned between the transparent conductive layer and the first semiconductor layer. The layer containing the second dopant can contact the transparent conductive layer. In other circumstances the layer containing the
25 dopant can contact the first semiconductor layer. The layer containing the second dopant, such as an n-type dopant, can have a thickness of about 5-15 Angstroms, for example.

Examples of n-type dopants include aluminum and indium. Conventionally, various defects in polycrystalline films have caused doping efficiency of semiconductor layers to remain low. In order to improve doping efficiency, a semiconductor layer can
30 be treated with an oxidant such as oxygen or fluorine. After defects of the semiconductor layer have been passivated with an oxidant, doping efficiency can be improved. Without

passivation, the addition of dopants such as In or Al can have negative effects. Thus, doping semiconductor layers in several stages can increase photovoltaic cell efficiency.

A dopant can be added intentionally as an extrinsic dopant. Photovoltaic cells are often processed without any intentional extrinsic dopants in a first semiconductor layer, such as a CdS containing layer, or without any extrinsic dopants in a second semiconductor layer, such as CdTe layer, or both. Doping the first semiconductor layer, or second semiconductor layer, or both, in several stages, can reduce photovoltaic cell instability and increase efficiency.

Referring to **Fig. 1**, a photovoltaic cell can include semiconductor layers that are doped in at least two stages. For example, a first semiconductor layer **100** can include CdS, for example. The first semiconductor layer, such as a CdS layer, can be treated with an oxidant **101**, such as oxygen or fluorine, to passivate the defects in the CdS layer. At this point the oxidant can be introduced at an interface between the transparent conductive layer and the CdS layer. The transparent conductive layer can include a transparent conductive oxide (TCO). Subsequently, a dopant **102**, such as an n-type dopant can be introduced. The dopant can be aluminum or indium, for example. The dopant can be introduced to the CdS layer. The dopant can be supplied by a source such as a carrier gas or by diffusion, either from the substrate **130**, from the TCO **120** itself, or from a surface layer **140** on the TCO. A second semiconductor layer **150** can be deposited over a first semiconductor layer. A second semiconductor layer can include CdTe, for example. A layer containing a dopant can have a thickness greater than 4 Angstroms, greater than 8 Angstroms, greater than 12 Angstroms, or approximately 15 Angstroms, for example. The structure of a photovoltaic device can also be reversed, for example, such that a transparent conductive layer is on a first semiconductor layer, the first semiconductor layer is on a second semiconductor layer, and the second semiconductor layer is on a metal layer.

Referring to **Fig. 2**, a first semiconductor layer, such as a CdS layer, can be treated with an oxidant **201**, such as oxygen or fluorine, to passivate the defects in the CdS layer. Subsequently, a dopant **202**, such as aluminum or indium can be introduced to the CdS layer. The dopant can be supplied by a source such as a carrier gas or by diffusion, either from the substrate **230**, from the TCO **220** itself, or from a surface layer on the TCO. The dopant can form a layer between a first semiconductor layer **200a** and an additional first semiconductor layer **200b**. The first semiconductor layer **200a** can have a thickness

greater than a thickness of the additional first semiconductor layer **200b**. For example, the thickness of the first semiconductor layer can be greater than 200 Angstroms, greater than greater than 400 Angstroms, and greater than 800 Angstroms, or approximately 900 Angstroms. The thickness of the additional first semiconductor layer can be greater than
5 50 Angstroms, greater than 75 Angstroms, or approximately 100 Angstroms. A second semiconductor layer **250** can be deposited over a first semiconductor layer. A second semiconductor layer can be treated with a second dopant. A second semiconductor layer can include CdTe, for example. A dopant layer can have a thickness greater than 4 Angstroms, greater than 8 Angstroms, greater than 12 Angstroms, or approximately 15
10 Angstroms, for example.

Referring to **Fig. 3**, a photovoltaic device can include a first semiconductor layer and a second semiconductor layer. Either the first semiconductor layer or the second semiconductor layer can include a dopant. Alternatively, both the first and second semiconductor layer can include a dopant. A first semiconductor layer **300** can include a
15 dopant **301**. Optionally, a second semiconductor layer **350** can include a dopant **302**. The first semiconductor layer can be supported by a substrate **330**.

Doping a semiconductor layer can be performed in several ways. For example, a dopant can be supplied from an incoming powder, such as a mixed powder (for example, CdS + In₂S₃), a carrier gas, or a directly doped powder such as CdS powder. The powder
20 can be a single or multiple phase material. In other circumstances, a dopant can be supplied by diffusion from a layer, such as a substrate layer, a transparent conductive layer, or a semiconductor layer. A dopant may be added throughout a semiconductor layer, or through a portion of a layer.

A dopant for a first semiconductor layer can be added by diffusion from the
25 transparent conductive layer or from a surface layer on the transparent conductive layer. Alternatively, a dopant for the first semiconductor layer can be added by an incoming powder or carrier gas fed into a vapor transport deposition system. A dopant for a first semiconductor layer can be volatilized along with the first semiconductor at temperatures less than 1500°C, less than 1400°C, less than 1200°C, less than 1000°C, or less than
30 800°C, for example. The volatile species can be atomic or a sulfide molecule, such as In₂S. Indium can be an effective dopant because it has a reasonably vapor pressure at typical CdS distributor temperatures (approximately 1100°C).

Doping a second semiconductor layer, such as CdTe, can be performed in several ways. For example, a dopant can be supplied along with a CdTe source powder into a vapor transport deposition (VTD) distributor system. The dopant for a second semiconductor layer can be introduced as a powder (i.e. a single or multiple phase material) or in a carrier gas. Alternatively, a dopant for a second semiconductor layer can be introduced by deposition of an outer layer onto the second semiconductor layer. For example, an outer layer may contain a dopant, which can diffuse into the CdTe layer.

P-type doping can be effective for a second semiconductor layer, such as CdTe. Group V (for example, N, P, As, Sb, or Bi) and Group I (for example, Li, Na, K, Rb, Cs, Cu, Ag, or Au) elements can be effective dopants for a second semiconductor layer. Phosphorous (P), arsenic (As), antimony (Sb), sodium (Na), potassium (K), rubidium (Rb) present no vaporization problems when introduced into the VTD system operating at typical CdTe distributor temperatures (approximately 900-1100°C).

A dopant for a second semiconductor layer can be introduced during heat treatment. Heat treatment can be performed with CdCl₂ flux. Group I and Group V species such as chloride compounds, can be added to the flux solution that is applied to an outer surface of the second semiconductor layer prior to heat treatment. During heat treatment, recrystallization can occur, thereby making doping distribution within the film possible.

Dopant incorporation can be affected by the concentration of vacancy defects. Vacancy concentration can be controlled by vapor phase overpressure. For example, excess Cd or Te can be applied to alter electronic defects in the final device. Cd or Te overpressure can be achieved by introduction of excess Cd or Te in the CdTe source powder. This can be achieved by a two-phase powder blend or by an off-stoichiometric source material. A material can be off-stoichiometric by greater than 5%, greater than 10%, or greater than 15%, such as approximately 20%.

A dopant can be applied in any concentration, for example, greater than 0.5 ppma, greater than 50 ppma, greater than 500 ppma, or between 1-1000 ppma, for example. Certain gas source dopants, such as those containing nitrogen, for example, may decompose too readily in a heated CdTe distributor, and thus, can be introduced in a secondary, lower temperature distribution system. Dopants can be added throughout an entire semiconductor layer, or into only a portion of the layer by using multi-layer VTD configuration, for example.

A CdS layer can be treated with a dopant such as indium in several ways. In one example, the incorporation of indium in a CdS layer via In_2S_3 and a source powder has resulted in improved luminescence. In another example, a CdS layer was doped directly with indium, and extra sulfur lead to an increase in indium incorporation.

5 A CdTe layer can also be treated with a dopant such as sodium in several ways. In one example, a CdTe layer was doped with sodium using Na_2S powder. The addition of Na resulted in changes in recrystallization during subsequent chloride heat treatment, suggesting that Na doping made the CdCl_2 recrystallization flux more active. Similar results were found with RbCl doping.

10 A CdTe layer can also be doped with P, As, Sb, Na, Rb, or Cu. In yet another example, a CdTe layer doped with Cu was shown to exhibit improved electrical signals. The addition of extra Te to the CdTe powder resulted in improved ability to dope the films. In addition, Cd-rich conditions resulted in a change in film grain structure suggesting the improved ability to dope the films.

15 A common photovoltaic cell can have multiple layers. The multiple layers can include a bottom layer that is a transparent conductive layer, a capping layer, a window layer, an absorber layer and a top layer. Each layer can be deposited at a different deposition station of a manufacturing line with a separate deposition gas supply and a vacuum-sealed deposition chamber at each station as required. The substrate can be
20 transferred from deposition station to deposition station via a rolling conveyor until all of the desired layers are deposited. Additional layers can be added using other techniques such as sputtering. Electrical conductors can be connected to the top and the bottom layers respectively to collect the electrical energy produced when solar energy is incident onto the absorber layer. A top substrate layer can be placed on top of the top layer to form
25 a sandwich and complete the photovoltaic cell.

 The bottom layer can be a transparent conductive layer, and can be, for example, a transparent conductive oxide such as tin oxide or tin oxide doped with fluorine. Deposition of a semiconductor layer at high temperature directly on the transparent conductive oxide layer can result in reactions that negatively impact of the performance
30 and stability of the photovoltaic device. Deposition of a capping layer of material with a high chemical stability (such as silicon dioxide, dialuminum trioxide, titanium dioxide, diboron trioxide and other similar entities) can significantly reduce the impact of these reactions on device performance and stability. The thickness of the capping layer should

be minimized because of the high resistivity of the material used. Otherwise a resistive block counter to the desired current flow may occur. A capping layer can reduce the surface roughness of the transparent conductive oxide layer by filling in irregularities in the surface, which can aid in deposition of the window layer and can allow the window layer to have a thinner cross-section. The reduced surface roughness can help improve the uniformity of the window layer. Other advantages of including the capping layer in photovoltaic cells can include improving optical clarity, improving consistency in band gap, providing better field strength at the junction and providing better device efficiency as measured by open circuit voltage. Capping layers are described, for example, in U.S. Patent Publication 20050257824, which is incorporated by reference in its entirety.

The window layer and the absorbing layer can include, for example, a binary semiconductor such as group II-VI, III-V or IV semiconductor, such as, for example, ZnO, ZnS, ZnSe, ZnTe, CdO, CdS, CdSe, CdTe, MgO, MgS, MgSe, MgTe, HgO, HgS, HgSe, HgTe, MnO, MnS, MnTe, AlN, AlP, AlAs, AlSb, GaN, GaP, GaAs, GaSb, InN, InP, InAs, InSb, TiN, TiP, TiAs, TiSb, or mixtures thereof. An example of a window layer and absorbing layer is a layer of CdS coated by a layer of CdTe. A top layer can cover the semiconductor layers. The top layer can include a metal such as, for example, aluminum, molybdenum, chromium, cobalt, nickel, titanium, tungsten, or alloys thereof. The top layer can also include metal oxides or metal nitrides or alloys thereof.

Deposition of semiconductor layers in the manufacture of photovoltaic devices is described, for example, in U.S. Pat. Nos. 5,248,349, 5,372,646, 5,470,397, 5,536,333, 5,945,163, 6,037,241, and 6,444,043, each of which is incorporated by reference in its entirety. The deposition can involve transport of vapor from a source to a substrate, or sublimation of a solid in a closed system. An apparatus for manufacturing photovoltaic cells can include a conveyor, for example a roll conveyor with rollers. Other types of conveyors are possible. The conveyor transports substrate into a series of one or more deposition stations for depositing layers of material on the exposed surface of the substrate. Conveyors are described in provisional U.S. Application 11/692,667, which is hereby incorporated by reference.

The deposition chamber can be heated to reach a processing temperature of not less than about 450° C and not more than about 700° C, for example the temperature can range from 450-550° C, 550-650° C, 570-600° C, 600-640° C or any other range greater

than 450° C and less than about 700° C. The deposition chamber includes a deposition distributor connected to a deposition vapor supply. The distributor can be connected to multiple vapor supplies for deposition of various layers or the substrate can be moved through multiple and various deposition stations with its own vapor distributor and supply. The distributor can be in the form of a spray nozzle with varying nozzle geometries to facilitate uniform distribution of the vapor supply.

The bottom layer of a photovoltaic cell can be a transparent conductive layer. A thin capping layer can be on top of and at least covering the transparent conductive layer in part. The next layer deposited is the first semiconductor layer, which can serve as a window layer and can be thinner based on the use of a transparent conductive layer and the capping layer. The next layer deposited is the second semiconductor layer, which serves as the absorber layer. Other layers, such as layers including dopants, can be deposited or otherwise placed on the substrate throughout the manufacturing process as needed.

The transparent conductive layer can be a transparent conductive oxide, such as a metallic oxide like tin oxide, which can be doped with, for example, fluorine. This layer can be deposited between the front contact and the first semiconductor layer, and can have a resistivity sufficiently high to reduce the effects of pinholes in the first semiconductor layer. Pinholes in the first semiconductor layer can result in shunt formation between the second semiconductor layer and the first contact resulting in a drain on the local field surrounding the pinhole. A small increase in the resistance of this pathway can dramatically reduce the area affected by the shunt.

A capping layer can be provided to supply this increase in resistance. The capping layer can be a very thin layer of a material with high chemical stability. The capping layer can have higher transparency than a comparable thickness of semiconductor material having the same thickness. Examples of materials that are suitable for use as a capping layer include silicon dioxide, dialuminum trioxide, titanium dioxide, diboron trioxide and other similar entities. Capping layer can also serve to isolate the transparent conductive layer electrically and chemically from the first semiconductor layer preventing reactions that occur at high temperature that can negatively impact performance and stability. The capping layer can also provide a conductive surface that can be more suitable for accepting deposition of the first

semiconductor layer. For example, the capping layer can provide a surface with decreased surface roughness.

The first semiconductor layer can serve as a window layer for the second semiconductor layer. The first semiconductor layer can be thinner than the second semiconductor layer. By being thinner, the first semiconductor layer can allow greater penetration of the shorter wavelengths of the incident light to the second semiconductor layer.

The first semiconductor layer can be a group II-VI, III-V or IV semiconductor, such as, for example, ZnO, ZnS, ZnSe, ZnTe, CdO, CdS, CdSe, CdTe, MgO, MgS, MgSe, MgTe, HgO, HgS, HgSe, HgTe, MnO, MnS, MnTe, AlN, AlP, AlAs, AlSb, GaN, GaP, GaAs, GaSb, InN, InP, InAs, InSb, TiN, TiP, TiAs, TiSb, or mixtures or alloys thereof. It can be a binary semiconductor, for example it can be CdS. The second semiconductor layer can be deposited onto the first semiconductor layer. The second semiconductor can serve as an absorber layer for the incident light when the first semiconductor layer is serving as a window layer. Similar to the first semiconductor layer, the second semiconductor layer can also be a group II-VI, III-V or IV semiconductor, such as, for example, ZnO, ZnS, ZnSe, ZnTe, CdO, CdS, CdSe, CdTe, MgO, MgS, MgSe, MgTe, HgO, HgS, HgSe, HgTe, MnO, MnS, MnTe, AlN, AlP, AlAs, AlSb, GaN, GaP, GaAs, GaSb, InN, InP, InAs, InSb, TiN, TiP, TiAs, TiSb, or mixtures thereof.

The second semiconductor layer can be deposited onto a first semiconductor layer. A capping layer can serve to isolate a transparent conductive layer electrically and chemically from the first semiconductor layer preventing reactions that occur at high temperature that can negatively impact performance and stability. The transparent conductive layer can be deposited over a substrate.

A number of embodiments have been described. Nevertheless, it will be understood that various modifications may be made without departing from the spirit and scope of the invention. For example, the semiconductor layers can include a variety of other materials, as can the materials used for the buffer layer and the capping layer. Accordingly, other embodiments are within the scope of the following claims.

WHAT IS CLAIMED IS:

1. A photovoltaic cell comprising:
 - a transparent conductive layer; and
 - a first semiconductor layer in contact with the transparent conductive
- 5 layer, wherein the first semiconductor layer includes an oxidant.
2. The photovoltaic cell of claim 1, wherein the transparent conductive layer is positioned over a substrate.
3. The photovoltaic cell of claim 1, wherein the transparent conductive layer is positioned over the first semiconductor layer.
- 10 4. The photovoltaic cell of claim 1, wherein the oxidant is fluorine or oxygen.
5. The photovoltaic cell of claim 1, further comprising a layer between the transparent conductive layer and the first semiconductor layer, wherein the layer contains a dopant.
6. The photovoltaic cell of claim 5, wherein the dopant includes an n-type dopant.
- 15 7. The dopant layer of claim 5, wherein the layer containing a dopant is in contact with the first semiconductor layer.
8. The dopant layer of claim 1, wherein the layer containing a dopant is in contact with the transparent conductive layer.
9. The photovoltaic cell of claim 1, further comprising a second semiconductor layer
- 20 in contact with the first semiconductor layer.
10. The photovoltaic cell of claim 9, wherein the second semiconductor layer comprises CdTe.
11. The photovoltaic cell of claim 1, wherein the first semiconductor layer comprises CdS.
- 25 12. The photovoltaic cell of claim 1, wherein the substrate is glass.
13. The photovoltaic cell of claim 1, further comprising an additional first semiconductor layer between the layer containing a dopant and the transparent conductive layer.
14. The photovoltaic cell of claim 13, wherein the layer containing a dopant has a
- 30 thickness greater than 4 Angstroms.
15. The photovoltaic cell of claim 13, wherein the layer containing a dopant has a thickness greater than 8 Angstroms.

16. The photovoltaic cell of claim 13, wherein the layer containing a dopant has a thickness greater than 12 Angstroms.

17. A photovoltaic cell comprising:

a transparent conductive layer;

5 a first semiconductor layer in contact with the transparent conductive layer,
and

a second semiconductor layer adjacent to the first semiconductor layer,
wherein the first or second semiconductor layer includes a dopant.

18. The photovoltaic cell of claim 17, wherein both the first and second
10 semiconductor layer includes a dopant.

19. The photovoltaic cell of claim 17 wherein the dopant in the first
semiconductor layer is different from the dopant in the second semiconductor
layer.

20. The photovoltaic cell of claim 17, wherein the transparent conductive layer is
15 positioned over a substrate.

21. The photovoltaic cell of claim 17, wherein the transparent conductive layer is
positioned over the first semiconductor layer.

22. The photovoltaic cell of claim 17, wherein the first semiconductor layer
comprises CdS.

20 23. The photovoltaic cell of claim 17, wherein the second semiconductor layer
comprises CdTe.

24. The photovoltaic cell of claim 17, wherein the dopant is a Group III species.

25. The photovoltaic cell of claim 17, wherein the dopant is a Group I species.

26. The photovoltaic cell of claim 17, wherein the dopant is Cu, Ag, or Au.

25 27. The photovoltaic cell of claim 17, wherein the dopant is a Group V species.

28. The photovoltaic cell of claim 17, wherein the dopant has a concentration of
greater than 0.5 ppma.

29. The photovoltaic cell of claim 17, wherein the dopant has a concentration
greater than 100 ppma.

30 30. The photovoltaic cell of claim 17, wherein the dopant has a concentration
greater than 500 ppma.

31. A method of manufacturing a photovoltaic cell comprising:
depositing a first semiconductor layer in contact with a transparent
conductive layer;
depositing a second semiconductor layer adjacent to the first
5 semiconductor layer; and
introducing a dopant in the first semiconductor layer or the second
semiconductor layer.
32. The method of claim 31 wherein a dopant is introduced to both the first and
second semiconductor layer.
- 10 33. The method of claim 32 wherein the dopant introduced to the first
semiconductor layer is different from the dopant introduced to the second
semiconductor layer.
34. The method of claim 31, wherein the first or second dopant is introduced by
diffusion.
- 15 35. The method of claim 31, wherein the dopant is introduced by a vapor.
36. The method of claim 31, wherein the dopant is introduced as a mixed powder.
37. The method of claim 31, wherein the dopant is introduced as a solid powder.
38. The method of claim 31, wherein the dopant is introduced throughout an
entire semiconductor layer.
- 20 39. The method of claim 31, wherein the dopant is added to a portion of a layer.
40. The method of claim 31, wherein the dopant is an n-type dopant.
41. The method of claim 31, wherein the dopant is a p-type dopant.
42. The method of claim 31, wherein the dopant is indium and the mixed powder
is CdS and In_2S_3 .
- 25 43. The method of claim 31, wherein the dopant is introduced during heat
treatment.
44. The method of claim 43, wherein the heat treatment temperature is about 400
degrees Celsius.
45. The method of claim 43, wherein a dopant is applied to a surface of the
30 second semiconductor layer prior to heat treatment.
46. A method of manufacturing a photovoltaic cell comprising:
depositing a first semiconductor layer in the presence of an oxidant; and
treating the first semiconductor layer with a dopant.

47. The method of claim 46, wherein the first semiconductor layer is positioned over a substrate.

48. The method of claim 46, wherein the first semiconductor layer is positioned over a metal layer.

5 49. The method of claim 46, wherein the oxidant is a fluorine or oxygen.

50. The method of claim 46, wherein the dopant includes an n-type dopant.

51. The method of claim 46, wherein the dopant includes aluminum or indium.

52. The method of claim 46, wherein the dopant is distributed as a layer within the first semiconductor layer.

10 53. A system for generating electrical energy comprising:

a multilayered photovoltaic cell, the photovoltaic cell including a transparent conductive layer, a first semiconductor layer in contact with a transparent conductive layer, and a second semiconductor layer over the first semiconductor layer, wherein the first or second semiconductor layer includes a dopant;

15 a first electrical connection connected to the transparent conductive layer; and

a second electrical connection connected to a metal layer.

54. The system of claim 53 wherein both the first and second semiconductor layer includes a dopant

20 55. The system of claim 53 wherein the dopant in the first semiconductor layer is different from the dopant in the second semiconductor layer.

56. The photovoltaic cell of claim 53, wherein the transparent conductive layer is positioned over a substrate.

25 57. The photovoltaic cell of claim 53, wherein the transparent conductive layer is positioned over the first semiconductor layer.

Fig. 1

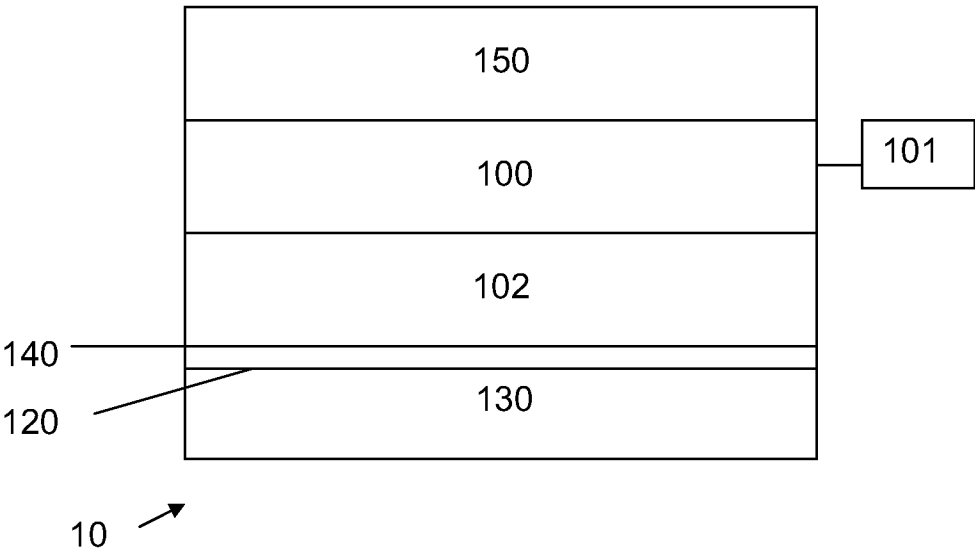


Fig. 2

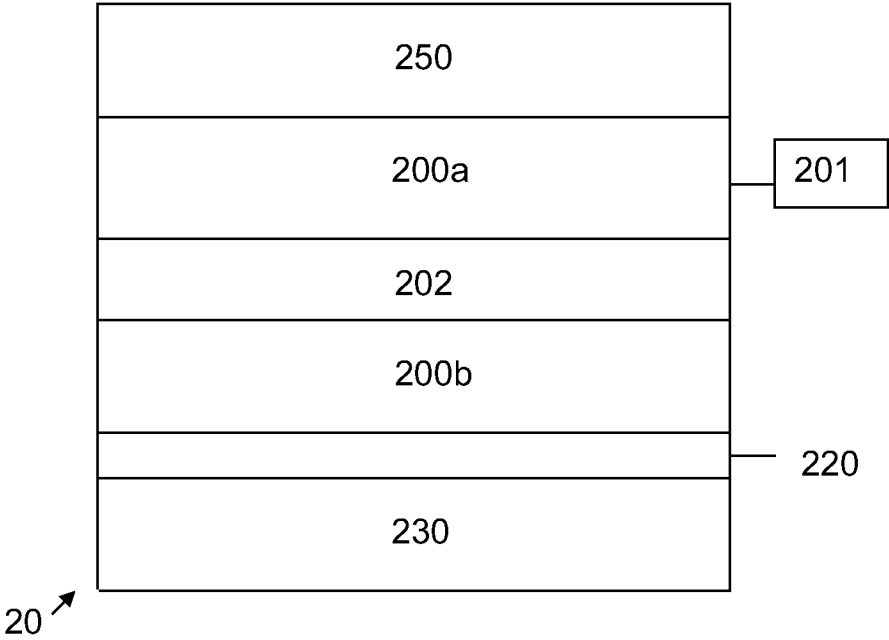
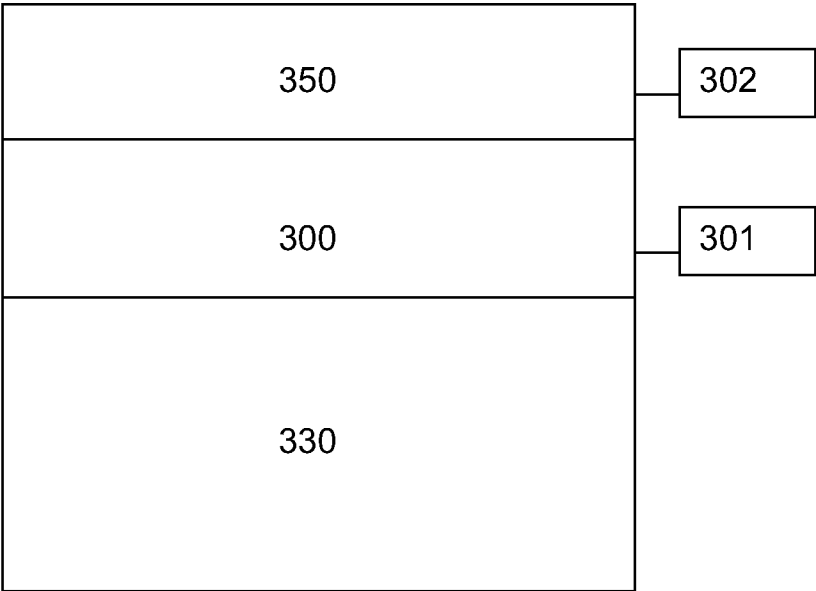


Fig. 3



INTERNATIONAL SEARCH REPORT

International application No.

PCT/US 08/81763

A. CLASSIFICATION OF SUBJECT MATTER

IPC(8) - H01L 31/00 (2009.01)

USPC - 136/258

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

USPC: 136/258

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
USPC: 136/249; 257/E25.009; 438/635

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

PubWEST(PGPB, USPT, USOC, EPAB, JPAB); GOOGLE

Search Terms Used: Photovoltaic cell, transparent conductive layer, semiconductor layer, dopant, angstrom, concentration, species, powder, mixed, solid, cdte, ppma.

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y	US 2005/0257824 A1 (Maltby et al.) 24 November 2005 (24.11.2005), entire document, especially; abstract, para. [0004], [0007], [0009], [0012], [0016], [0021].	1-57
Y	US 2006/0130891 A1 (Carlson) 22 June 2006 (22.06.2006), entire document, especially; abstract, para. [0024]-[0029], [0037], [0047].	1-57
Y	US 6,482,719 B1 (Anjum et al.) 19 November 2002 (19.11.2002), entire document, especially; abstract, Col 4, ln 19-41; Col 5, ln 57-65; Col 6, ln 32-56.	24, 25, 27
Y	US 2002/0114128 A1 (Ryu et al.) 22 August 2002 (22.08.2002), entire document, especially; abstract, para. [0050].	36, 37

☐ Further documents are listed in the continuation of Box C.

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"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone

"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art

"&" document member of the same patent family

Date of the actual completion of the international search

06 January 2009 (06.01.2009)

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